

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Maud Vinet et al.
SERIAL NO.: 10/539,532
FILING DATE: June 17, 2005 CONFIRMATION No.: 4554
TITLE: Method For Forming Patterns Aligned On Either Side Of A Thin Film
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AMENDMENT AND RESPONSE AFTER FINAL OFFICE ACTION UNDER

37 CFR 1.116

Dear Sir:

This paper is responsive to the Advisory Action mailed April 30, 2008. Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.